



PATENT

Rev 06/04

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE


In re application : Tadashi Aiura et al.
Application No. : 09/341,339
Filed : August 30, 1999
Confirmation No. : 5010
For : METHOD AND APPARATUS FOR POLISHING
INTERNAL SURFACE OF LONG SIZED
CYLINDRICAL WORKPIECES AND LONG SIZED
CYLINDRICAL WORKPIECES
Examiner : Hadi Shakeri
Attorney's Docket : AK-284XX

TC Art Unit: 3723

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AMENDMENT

Via Facsimile
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 16, 2004,
please amend the above-identified patent application as follows.